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	Applicati n No.	Applicant(s)
Notice of Allowability	09/875,698	PYO, SUNG GYU
	Examin r	Art Unit
	Lynette T. Umez-Eronini	1765
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communicatio IGHTS. This application is subject	oplication. If not included n will be mailed in due course. THIS
1. This communication is responsive to <u>12/3/03</u> .		
2. The allowed claim(s) is/are 1-11.		
 3. The drawings filed on <u>06 June 2001</u> are accepted by the Examiner. 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some* c) None of the: 		
1. ☐ Certified copies of the priority documents have been received.		
2. Certified copies of the priority documents have been received in Application No		
3. Copies of the certified copies of the priority documents have been received in this national stage application from the		
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received: 5. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application) since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78. (a) The translation of the foreign language provisional application has been received. 6. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121 since a specific reference was included in the first sentence of the specification or in an Application Data Sheet. 37 CFR 1.78.		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE		
7. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.		
 8. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No. (b) including changes required by the proposed drawing correction filed, which has been approved by the Examiner. (c) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No. 		
Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the margin according to 37 CFR 1.121(d).		
9. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT FOR T		
Attachm nt(s)		
1☐ Notice of References Cited (PTO-892)	5☐ Notice of Informal P	atent Application (PTO-152)
2☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08		(PTO-413), Paper No
Paper No. 6 4 Examiner's Comment Regarding Requirement for Deposit	8⊠ Examiner's Stateme	nt of Reasons for Allowance
of Biological Material	9 <u> </u>	

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REASON FOR ALLOWANCE

1. Claims 1-11 are allowed.

2. The following is an examiner's statement of reasons for allowance: In view of the

English translation of Korean priority applicant 2000-330980 (filed 6/20/00) that was

submitted on December 3, 2003, the 103 rejection of claims 1-11 over Li in view of Koh

and further in view of Liu is improper due to disqualification of Koh as prior art. Hence,

combination of the prior art fails to render it obvious in selectively forming chemical

enhancer layers on the portion of the second insulating film forming the bottom of the

trench and on the portion of the lower metal layer forming the bottom of the via; and

forming a copper layer on the chemical enhancer layers by means of chemical vapor

deposition method in a method of forming metal wiring in a semiconductor device along

with the other limitations of claims 1-11.

Any comments considered necessary by applicant must be submitted no later

than the payment of the issue fee and, to avoid processing delays, should preferably

accompany the issue fee. Such submissions should be clearly labeled "Comments on

Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Lynette T. Umez-Eronini whose telephone number is

571-272-1470. The examiner is normally unavailable on the First Friday.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on 571-272-1435. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Itue

December 16, 2003

ROBERT KUNEMUND PRIMARY EXAMINER